

Notice of References Cited	Application/Control No. 10/713,605		Applicant(s)/Patent Under Reexamination DEVAL ET AL.	
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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0189920	10-2003	Erami et al.	370/351
*	B	US-2002/0083260	06-2002	McCormick et al.	710/316
*	C	US-2005/0089027	04-2005	Colton, John R.	370/380
*	D	US-6,477,291	11-2002	Ramadas, Krishna Kumar	385/17
*	E	US-2004/0264960	12-2004	Maciocco et al.	398/049
*	F	US-2004/0066782	04-2004	Nassar, Ayman Esam	370/389
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	O					
	P					
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	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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